

Supporting Information
for
**Preparation and morphology-dependent wettability of porous
alumina membranes**

Dmitry L. Shimanovich¹, Alla I. Vorobjova^{*1}, Daria I. Tishkevich², Alex V. Trukhanov², Maxim V. Zdorovets^{3,4,5}, and Artem L. Kozlovskiy^{3,4}

Address: ¹Belarusian State University of Informatics and Radioelectronics, P. Brovki 6, Minsk 220013, Belarus, ²Scientific and Practical Materials Research Center, Institute of Semiconductor and Solid State Physics, National Academy of Sciences of Belarus, P. Brovki 19, Minsk 220072, Belarus, ³L. N. Gumilyov Eurasian National University, Abylaykhan, 2/1, Astana 010008, Kazakhstan, ⁴The Institute of Nuclear Physics of Republic of Kazakhstan, Ibragimova 1, Almaty 050032, Kazakhstan, and ⁵Ural Federal University, Mira 19, Yekaterinburg 620002, Russia

* Corresponding author

Email: Alla I. Vorobjova - vorobjova@bsuir.by

Additional experimental data

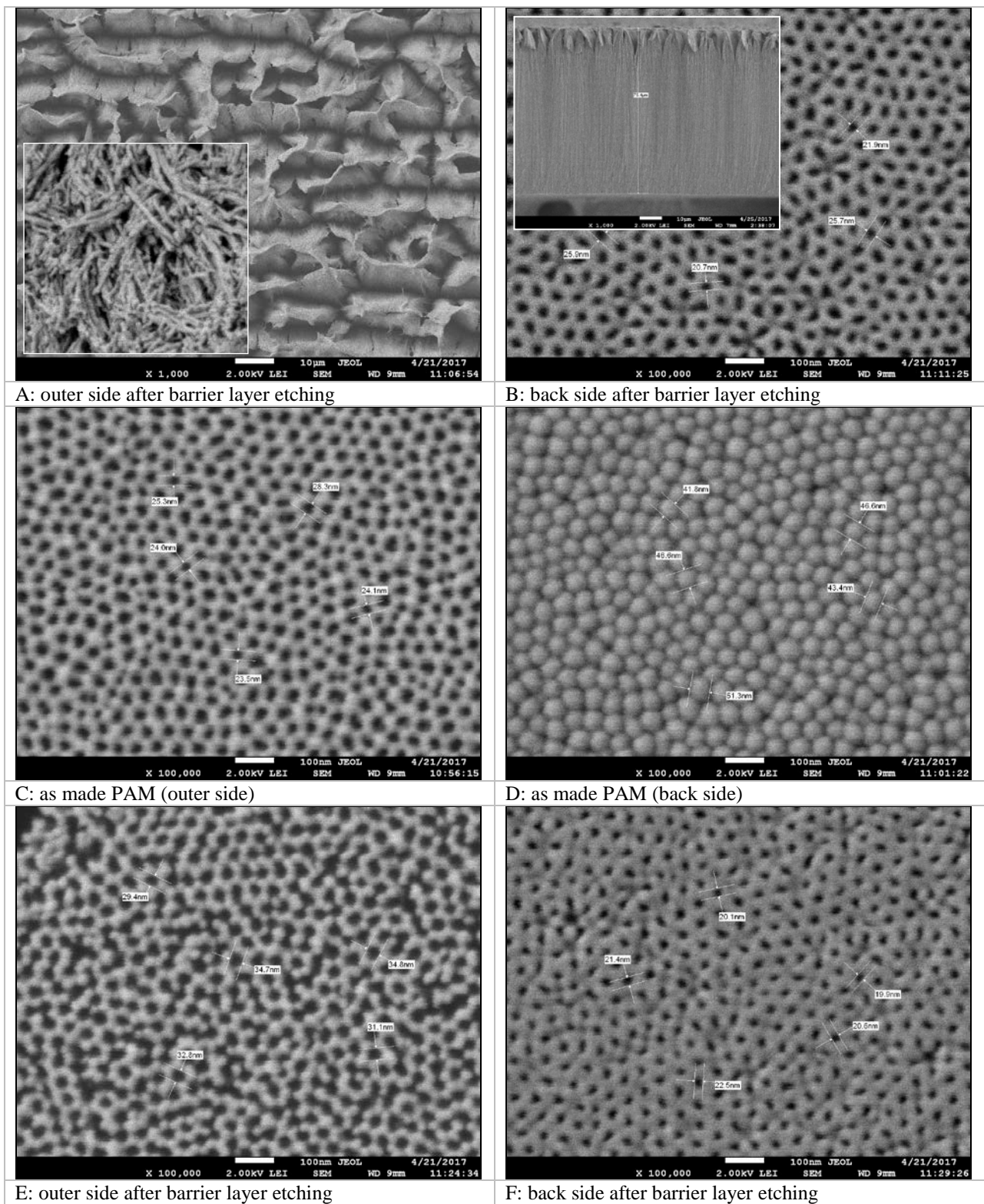


Figure S1: SEM images of PAM (III) with size of 70×70 mm of $75 \mu\text{m}$ thickness before and after barrier layer etching.